TC 2800

JC13 U.S. PTO
09/994279
11/26/01

ISSUE CLASSIFICATION	
Class	Subclass
438	905

5

PATENT NUMBER

U.S. **UTILITY** Patent Application

O.I.P.E.
SCANNED Q.A.

PATENT DATE

APPLICATION NO.	CONT/PRIOR	CLASS	SUBCLASS	ART UNIT	EXAMINER
09/994279	D	438	905	2812	

APPLICANTS Tory Chiang
Mark Leavey

TITLE Method for integrated in-situ inspection and cleaning of atomic layer deposition within a vacuum processing chamber

PTO-2040
12/99

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Date Paid

ISSUE BATCH NUMBER

(Date)

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